

<b>Notice of References Cited</b>	Application/Control No. 10/775,290	Applicant(s)/Patent Under Reexamination LIU et al.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2005/0136676	06-2005	Liu, Chia-Chen	438/703
	B	US-2003/0181053	09-2003	Tseng et al.	438/694
	C	US-2002/0093044	07-2002	Hsieh et al.	257/315
	D	US-6,875,658	04-2005	Yang, Hsiao-Ying	438/275
	E	US-6,790,123	09-2004	Korovin et al.	451/5
	F	US-6,165,843	12-2000	Sung, Kuo-Tung	438/258
	G	US-6,063,657	05-2000	Bronner et al.	438/244
	H	US-5,879,992	03-1999	Hsieh et al.	438/264
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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